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Title of Invention:	DUAL SILICIDE VIA CONTACT STRUCTURE AND PROCESS
First Named Inventor:	Michael M. Iwatake
Customer Number:	32074
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Supplemental Appeal Brief	FIS920040156_NON_COMPLIANT_APPEAL_BRIEF.pdf	277297	no	9

Warnings:	
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